

PROCESSING APPARATUS AND WORKPIECE PROCESSING METHOD

ABSTRACT OF THE DISCLOSURE

A processing apparatus includes a chuck table configured to hold a workpiece by a holding surface, a processing unit configured to process the workpiece held by the chuck table, a moving mechanism configured to move the chuck table and the processing unit relative to each other along a direction parallel with the holding surface of the chuck table, an angle control mechanism disposed on the moving mechanism and on a lower side of the chuck table, the angle control mechanism controlling an angle of the chuck table, and an imaging unit configured to image the workpiece held by the chuck table, the chuck table including a holding member formed by a transparent body and holding the workpiece and a supporting member supporting a part of the holding member and connected to the angle control mechanism.

[Fig. 1]